



00862.022476.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshikazu MIYAJIMA et al.) : Examiner: R. Fuller
Application No.: 10/022,506) : Group Art Unit: 2851
Filed: December 20, 2001) : Confirmation No.: 2840
For: EXPOSURE APPARATUS, DEVICE) : Allowed: October 27, 2003
MANUFACTURING METHOD,) : January 27, 2004
SEMICONDUCTOR MANUFACTURING)
FACTORY, AND EXPOSURE APPARATUS :
MAINTENANCE METHOD)

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

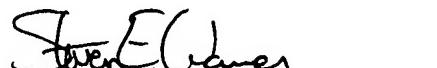
Sir:

Transmitted herewith are eight (8) formal drawing sheets, corrected Figures 19A-22, 24A-26B and 28A-28C, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

Figures 19A-22, 24A-26B and 28A-28C incorporate the changes requested by Applicants in a Request for Approval of Drawing Changes, filed April 14, 2003, which were subsequently approved by the Examiner in the Notice of Allowability dated October 27, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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